10/15/01 JC975 U.S. PTO

10-17-01

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Docket No. 005794 ALRT/ETCH/CONE/

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

09/978121 JC857 U.S. PTO 10/15/01

Re: Inventor(s): Mark N. Kawaguchi, Huong T. Nguyen, Nikolaos Bekiaris, James S. Papanu
Title: A METHOD OF PHOTORESIST REMOVAL IN THE PRESENCE OF A DIELECTRIC LAYER HAVING A LOW K-VALUE

Transmitted herewith is the patent application identified above, including:

X Specification, claims and abstract, totaling 35 pages.

X Drawings totaling 6 pages, __ Formal X Informal.

X Executed Declaration and Power of Attorney.

X Assignment of the invention to **Applied Materials, Inc.**

X Assignment Recordation Cover Sheet

FEE CALCULATION

Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	25	- 20 =	5	X $18.00	$ 90.00
Independent Claims	2	- 3 =	0	X $80.00	0.00
Basic Filing Fee				$740.00	$740.00
TOTAL FEES					$830.00

XX The Commissioner is hereby authorized to charge $830.00 to Deposit Account No. 50-1074.

XX The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. **50-1074**. A duplicate copy of this transmittal is enclosed.

XX Please address all future correspondence to:

PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O. Box 450A
Santa Clara, CA 95052

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Box Patent Application, Assistant Commissioner for Patents, Washington, D.C. 20231.

Express Mail Receipt No. EL 672745889 US

Date of Deposit 10-15-01

Signature Ruth Mulcahy

Respectfully submitted,

Robert W. Mulcahy
Registration No. 25,436